

Receipt date: 05/28/2009

Docket Number (Optional)

42479-9400

Applicant Number- GAU: 1793

10/581,578

**INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

Applicant(s)

Satoshi Hayashi et al.

Filing Date

December 26, 2006

Group Art Unit

1793

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		3,835,064	9.10.1974	Shinomiya et al.			

**U.S. PATENT APPLICATION PUBLICATIONS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/0010093	1.24.2002	Monereau et al.			

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER

/Brian Walck/

DATE CONSIDERED

11/19/2009

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.